Contents

xiii Symposium Committee

xv Introduction

xvii AOMATT 2012 Sponsors

INVITED SESSION

8416 02 Research on fabrication of mirror segments for E-ELT (Invited Paper) [8416-205]
G. Yu, OptiC Glyndwr Ltd. (United Kingdom); D. D. Walker, OptiC Glyndwr Ltd. (United
Kingdom), Univ. College London (United Kingdom), and Zeeko Ltd. (United Kingdom); H. Li, 
Univ. College London (United Kingdom)

8416 03 Development of a flexible and reliable numerical simulation for precision glass molding of 
complex glass optics (Invited Paper) [8416-35]
F. Klocke, F. Wang, Y. Wang, G. Liu, O. Dombon, Fraunhofer Institute for Production 
Technology (Germany); A. Y. Yi, The Ohio State Univ. (United States)

8416 04 Asphere metrology using variable optical null technology (Invited Paper) [8416-204]
C. Supranowitz, C. McFee, P. Murphy, QED Technologies, Inc. (United States)

SESSION 2-1

8416 05 Numerical simulation of temperature field and experimental inquiry of TC4 titanium alloy 
laser rapid forming [8416-1]
Y. Lai, Shenyang Institute of Automation (China) and Graduate Univ. of Chinese Academy 
of Sciences (China); W. Liu, Shenyang Institute of Automation (China); Y. Kong, F. Wang, 
Shenyang Institute of Automation (China) and Graduate Univ. of Chinese Academy of 
Sciences (China); Y. Zhao, Shenyang Institute of Automation (China)

8416 06 Precision manufacturing of fused silica glass by combining bound-abrasive polishing with 
ultrasonic vibration [8416-53]
Y. Li, Akita Prefectural Univ. (Japan) and Chengdu Fine Optical Engineering Research Ctr. 
(China); Y. Wu, Akita Prefectural Univ. (Japan); J. Wang, Q. Xu, Chengdu Fine Optical 
Engineering Research Ctr. (China); W. Yang, Y. Guo, Xiamen Univ. (China)

8416 07 A large ion beam figuring plant used for manufacturing astronomical telescope [8416-61]
W. Guo, B. Liang, X. Cheng, Y. Zheng, Nanjing Institute of Astronomical Optics & 
Technology (China)

8416 08 Progresses in optical design and simulation optimization methods [8416-73]
H. Liu, Q. Ding, National Key Lab. of Science and Technology on Fire Control (China); 
L. Zhou, Beijing Institute of Technology (China)
8416 09  Supersmooth polishing with sub-angstrom roughness [8416-75]
J. Wang, Changchun Institute of Optics, Fine Mechanics and Physics (China)

8416 0A  Lapping application research for touch screen glass using 3M fine grade Trizact diamond tile [8416-94]
L. Zheng, 3M South China Technical Ctr. (China); T. K. Na, 3M R&D Ctr. (Singapore)

8416 0B  Novel method for fabricating steep aspheric mirrors [8416-107]
Y. Shu, S. Li, X. Zuo, C. Song, Y. Wang, National Univ. of Defense Technology (China)

SESSION 2-2

8416 0C  An integrated approach for design, ultraprecision polishing, and measurement of freeform progressive lenses [8416-102]
C. F. Cheung, L. B. Kong, L. T. Ho, S. To, B. Wang, K. T. Lai, The Hong Kong Polytechnic Univ. (Hong Kong, China)

8416 0D  Development of an externally pressurized bearing-rotor system for a five-axis ultraprecision machine tool used for optical manufacture and the static performance analysis of the externally pressurized bearing [8416-47]
E. Qi, Z. Fang, T. Sun, J. Zhou, G. Hou, Harbin Institute of Technology (China)

8416 0E  Study on combination technology in off-axis asphere manufacture [8416-500]
Y. Wang, S. Li, X. Peng, X. Nie, C. Song, National Univ. of Defense Technology (China)

8416 0F  Insights into effects of thermal annealing on optical properties of SiO2 films [8416-51]
Y. Jiang, Tongji Univ. (China) and Tianjin Jinhang Institute of Technical Physics (China); Y. Ji, Tianjin Jinhang Institute of Technical Physics (China) and Harbin Institute of Technology (China); H. Liu, D. Liu, L. Wang, C. Jiang, Tianjin Jinhang Institute of Technical Physics (China); Y. Yang, Tongji Univ. (China); D. Chen, Harbin Institute of Technology (China)

8416 0G  Study on UVC ultraviolet filter film [8416-19]
Y. Kou, X. Fu, D. Liu, H. Zhu, H. Tang, Changchun Univ. of Science and Technology (China)

SESSION 2-3

8416 0H  Study on the synthesis and optical properties of polyurethane-imide [8416-203]
L. D. Wang, Southeast Univ. (China) and Huainan Normal Univ. (China); T. Zhang, X.-Y. Zhang, R.-Z. Li, L.-N. Wang, S.-Q. Zhu, Southeast Univ. (China)

8416 0I  Illuminator design for small field ArF lithography system [8416-145]
L. Wei, Y. Li, K. Liu, X. Liu, Beijing Institute of Technology (China)

8416 0J  Data filtering of optical freeform measurement based on a modified 2D cascaded approximating spline filter [8416-109]
Q. Wang, X. Zhang, Y. Peng, F. Fang, Tianjin Univ. (China)
POSTER SESSION

8416 OK Evolution and control of optical thin film stress [8416-206]
M. Fang, Shanghai Institute of Optics and Fine Mechanics (China); J. Li, Shanghai Institute of Optics and Fine Mechanics (China) and Graduate Univ. of Chinese Academy of Sciences (China); H. He, Z. Fan, Q. Xiao, Z. Y. Li, Shanghai Institute of Optics and Fine Mechanics (China)

8416 OL An on-line condition monitoring and monitoring point position visual system in grinding [8416-11]
W. Han, W. Yang, Y. Guo, T. Jiang, C. J. Wang, Xiamen Univ. (China)

8416 OM High performance narrow band-pass filter for the NIR/MWIR range [8416-69]
X. Su, W. Wu, K. Yan, F. Chen, C. Meng, LuoYang Optoelectro Technology Development Ctr. (China)

8416 ON Tri-rotors movement in computer controlled optical surfacing [8416-83]
X. Chen, P. Guo, J. Ren, Soochow Univ. (China)

8416 OO The research on making large-size aspherical mirrors by vacuum evaporation technique [8416-207]
J. Wang, Nanjing Institute of Astronomical Optics & Technology (China)

8416 OP Polishing large-aperture mirror using ultraprecise Bonnet and PSD result analysis [8416-98]
W. Wang, M. Xu, Fudan Univ. (China); H. Li, Harbin Institute of Technology (China), Univ. College London (United Kingdom), and OptIC Glyndwr Ltd. (United Kingdom); G. Yu, OptIC Glyndwr Ltd. (United Kingdom)

8416 OQ Optimum parameters for precision compression molding of spherical glass-lens arrays [8416-7]
J. Lu, J. Wang, M. Xu, H. Zhang, Fudan Univ. (China)

8416 OR Manufacturing technology of lightweight mirror for space optics [8416-9]
Y. Chen, J. Xie, Changchun Institute of Optics, Fine Mechanics and Physics (China)

8416 OS Design and manufacture of anti-IR thin films for resin lens [8416-15]
J. Chen, H. Feng, H. Chen, C. Hu, Y. Li, Wenzhou Medical College (China)

8416 OT An adaptive interpolation method for tool path generation based on iso-phote for large scale wedge /aspheric lens element grinding [8416-5]
N. Zhang, Xiamen Univ. (China) and Zhejiang Univ. of Technology (China); F. Yang, D. Zhang, M. Chen, Z. Wang, Y. Guo, Xiamen Univ. (China)

8416 OU Goniometer system of vehicle anti-tank missile design [8416-208]
M. Yan, X. Shan, H. Zhao, Changchun Institute of Technology (China)
Influence of substrate rotating on the microstructure and surface morphology of Ge and Si thin films [8416-21]
H. Luo, Shanghai Institute of Technical Physics (China) and Graduate Univ. of Chinese Academy of Sciences (China); D. Liu, Shanghai Institute of Technical Physics (China); X. Yin, Shanghai Institute of Technical Physics (China) and Graduate Univ. of Chinese Academy of Sciences (China)

Study on the applications of high-precision optical wedge machining, assembling, and adjustment technologies [8416-30]
Y. Su, R. Guo, J. Shi, Y. Zhang, F. Zhang, X. Liu, H. Zhao, Xi'an Institute of Applied Optics (China)

High efficient and ultra-precision machining of large scale SiC plane reflectors [8416-24]
R. Guo, Y. Su, C. Chen, Y. Zhang, F. Zhang, X. Liu, Xi'an Institute of Applied Optics (China)

Effects analysis of large area polishing tool on aspheric surface quality [8416-33]
Y. Zhang, F. Zhang, J. Yan, Y. Su, R. Guo, X. Liu, Xi'an Institute of Applied Optics (China)

Fabrication and measurement of toric lens [8416-34]
X. Liu, Y. Su, H. He, Y. Zhang, R. Guo, F. Zhang, Xi'an Institute of Applied Optics (China)

Aspheric surface profile effects analysis in polishing with ballonet polishing tool [8416-25]
F. Zhang, Y. Zhang, Xi'an Institute of Applied Optics (China); W. Kang, Xi'an North Optoeletronic Science and Technology Defense Co. Ltd. (China); Y. Su, C. Chen, X. Liu, Xi'an Institute of Applied Optics (China)

Design and fabrication of high efficiency diffuser film based on laser speckle [8416-23]
Y. Li, X. Ren, S. Liu, Xiamen Univ. (China)

Bonnet polishing high-slope aspheric surface [8416-108]
J. Zhang, Changchun Institute of Optics, Fine Mechanics and Physics (China)

Study on range selection of key parameters in bonnet polishing using FEA [8416-10]
R. Pan, Z. Wang, D. Zhang, C. Wang, Y. Xie, Y. Guo, Xiamen Univ. (China)

Research on a two ball lens system POF connector [8416-54]
Z. Huang, G. Liu, Z. Ren, L. Zeng, Q. Wan, Jiangxi Science and Technology Normal Univ. (China)

Simulation of high-resolution linear CCD satellite image [8416-92]
R. Zhang, S. Luo, G.-W. Jiang, T. Jiang, Information Engineering Univ. (China); M. Sun, People's Liberation Army (China)

Study on object-oriented petri net in modeling for infrared dome optical manufacturing [8416-45]
H. Wang, Northwestern Polytechnical Univ. (China) and LuoYang Optoelectro Technology Development Ctr. (China); H. Chen, LuoYang Optoelectro Technology Development Ctr. (China)

Custom design of aspherical RGP contact lens [8416-16]
C. Hu, Y. Li, J. Chen, Y. Wang, S. Chen, H. Chen, Wenzhou Medical College (China)
8416 1B **Study on the optical manufacture and testing methods of a refractive-reflective meniscus primary mirror** [8416-93]
J. Kang, Changchun Institute of Optics, Fine Mechanics and Physics (China) and Graduate Univ. of Chinese Academy of Sciences (China); B. Xuan, Changchun Institute of Optics, Fine Mechanics and Physics (China); J. Xie, Graduate Univ. of Chinese Academy of Sciences (China)

8416 19 **Key technologies for diamond turning of non-rotational symmetrical micro-structured surfaces** [8416-43]
J. Zhou, T. Sun, G. Hou, E. Qi, Harbin Institute of Technology (China)

8416 1A **An efficient CNC polishing technology of aspherical parabolic cylindrical lens** [8416-64]
Q. Huang, H. Chen, S. Hu, LuoYang Optoelectro Technology Development Ctr. (China)

8416 1B **Effects of structured surface errors on MTF of off-axis TMA system** [8416-13]
X. Zeng, Changchun Institute of Optics, Fine Mechanics and Physics (China) and Graduate Univ. of Chinese Academy of Sciences (China); F. Yan, X. Zhang, Changchun Institute of Optics, Fine Mechanics and Physics (China)

8416 1C **The study on errors of prisms of a quarter-width camera system** [8416-138]
P. Xie, L. Xing, Changchun Institute of Optics, Fine Mechanics and Physics (China)

8416 1D **Study on the control of surface roughness in single point diamond turning** [8416-56]
H. Xu, X. Zhang, Fudan Univ. (China); M. Xu, Fudan Univ. (China) and Modern Advanced Ultra-Precision Manufacturing Ctr. (China); X. Li, Modern Advanced Ultra-Precision Manufacturing Ctr. (China)

8416 1E **Magnetic medium assistant polishing technology and experiments** [8416-135]

8416 1F **Aging effect of optical properties on SiO2 films grown on Si substrates by ion beam sputtering** [8416-77]
Y. Ji, Harbin Institute of Technology (China) and Tianjin Jinhang Institute of Technical Physics (China); H. Liu, Tianjin Jinhang Institute of Technical Physics (China); Y. Jiang, Tianjin Jinhang Institute of Technical Physics (China) and Tongji Univ. (China); D. Liu, L. Wang, C. Jiang, Tianjin Jinhang Institute of Technical Physics (China); R. Fan, D. Chen, Harbin Institute of Technology (China)

8416 1G **Design and manufacture of high reflective coatings deposited on metal substrate** [8416-101]
L. Wang, H. Liu, Y. Jiang, C. Jiang, Y. Ji, Tianjin Jinhang Institute of Technical Physics (China)

8416 1H **Multi-channel optical telescope with free-form surface splitters** [8416-89]
X. Li, M. Xu, Fudan Univ. (China); X. Ren, Jining Medical Univ. (China)

8416 1I **Optimization of freeform cylindrical lens in Czerny-Turner spectrometer system to correct the astigmatism by using user defined error function** [8416-22]
B. Qu, G. Xia, F. Yu, Zhejiang Univ. (China)
Analysis and optimization of tooth shapes of roll stampers for optical micro-structured array imprinting [8416-131]
S. Yang, X. Zhang, M. Xu, Fudan Univ. (China)

Eight-axis-polishing machine for 2 m off-axis aspheric optics [8416-209]

Investigation on the MTF for the large-aperture long focal length TDICCD camera [8416-57]
J. Xin, Beijing Institute of Space Mechanics and Electricity (China)

Correction of full spatial frequency errors with ion beam figuring [8416-104]
Y. Gu, Changchun Institute of Optics, Fine Mechanics and Physics (China) and Graduate Univ. of Chinese Academy of Sciences (China)

Analysis of chemical polishing for optical elements [8416-88]
L. Jiao, Y. Jin, N. Lin, T. Liu, Y. Tong, D. Wu, C. Hui, Tianjin Jinhang Institute of Technical Physics (China)

Ultra-precision surface polishing using ion beam figuring [8416-31]
Y.-S. Ghim, S.-J. You, H.-G. Rhee, H.-S. Yang, Y.-W. Lee, Korea Research Institute of Standards and Science (Korea, Republic of)

Design of primary mirror supporting structure and lightweight of space camera [8416-154]
C. Zhu, T. Xu, Tongji Univ. (China); S. Liu, B. Yang, Y. Liu, Shanghai Institute of Technical Physics (China)

Anti-reflection coating on calcium fluoride substrate using ion-assisted deposition [8416-80]
Y. Zhang, J. Fan, H. Xu, Institute of Optics and Electronics (China)

Research on spectral calibration for hyper-spectral imager [8416-200]
Y. Guo, Y. Li, X. Zong, Beijing Institute of Space Mechanics and Electricity (China)

Rigidity controllable polishing tool based on magnetorheological effect [8416-41]
J. Wang, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); Y. Wan, C. Shi, Institute of Optics and Electronics (China)

Application of two-sided prisms in pyramid wavefront sensor [8416-71]
J. Wang, Southwest Univ. of Science and Technology (China) and Institute of Optics and Electronics (China); C. Guan, Institute of Optics and Electronics (China)

Laser beam shaping and packaging system [8416-85]
D. Luo, B. Zhao, Institute of Semiconductors (China)

The exploration of cloud manufacturing service mode for high power laser optical elements [8416-132]
J. Wang, J. Wang, Y. Tao, H. Li, W. Li, L. Jiang, Institute of Computer Application (China)

Effect of hydrodynamic pressure on ultraprecision grinding [8416-210]
Y. Hwang, H.-J. Kim, J.-H. Kim, Korea Photonics Technology Institute (Korea, Republic of)
Machining simulation of off-axis parabolic hexagonal mirrors [8416-36]
X. Feng, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); B. Fan, Institute of Optics and Electronics (China)

Study on the best arrangement of sensors used in the deformation measurement of active lap based on genetic algorithm [8416-38]
H. Zhao, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); X. Li, Z. Zeng, Institute of Optics and Electronics (China)

Introduction and manufacturing of oblate spheroid mirror [8416-211]
D. Li, L. Yuan, L. He, B. Wang, Nanjing Institute of Astronomical Optics & Technology (China)

Ultraprecision optical fabrication on fused silica [8416-76]
J. Wang, Changchun Institute of Optics, Fine Mechanics and Physics (China)

Generation of radially polarized femtosecond pulse beam with a polarization plates array [8416-130]
J. Qi, National Univ. of Defense Technology (China) and Military Academy of PLA (China); Y. Nie, X. Wang, J. Liao, J. Liu, J. Yang, H. Jia, X. Li, National Univ. of Defense Technology (China)

Mathematical model for active lap to achieve unsymmetrical fabrication [8416-65]
H. Liu, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); Z. Zeng, F. Wu, B. Fan, Institute of Optics and Electronics (China)

A study of new optimization of LED projector with high efficiency and contrast [8416-212]
Y.-C. Fang, C.-A. Chen, National Kaohsiung First Univ. of Science and Technology (Taiwan); C.-M. Tsai, Kun Shan Univ. (Taiwan); C.-T. Yen, National Formosa Univ. (Taiwan); H.-Y. Wu, C.-H. Chu, National Kaohsiung First Univ. of Science and Technology (Taiwan)

Preform rod feeding module of the optical fiber drawing tower and its algorithm design based on STM32 [8416-156]
T. Zhang, Z. Fan, G. Liu, T. Geng, X. Li, Harbin Engineering Univ. (China)

Reconstructing in laser wavelength scanning interference test of aspheric surface [8416-202]
L. Li, Institute of Optics and Electronics (China) and Sichuan Univ. (China); W. Zhao, Institute of Optics and Electronics (China); X. Su, Sichuan Univ. (China); F. Wu, B. Fan, Institute of Optics and Electronics (China)

Experimental study of grinding removal efficiency in optical processing for using NC manipulator [8416-91]
W. Zhang, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); Z. Zeng, F. Wu, B. Zhuo, Institute of Optics and Electronics (China)

A new method of calibrating the spatial coordinate coherence of shadowgraph-taking camera stations at the long distance with PSD [8416-58]
J. Li, X. Wang, H. Shen, R. Zhu, Y. Huang, S. Rong, Y. Bian, Nanjing Univ. of Science and Technology (China)
8416 2B Effects of colloid rheological characters in ultra-smooth polishing by nanoparticle colloid jet machining [8416-90]
X. Song, Lanzhou Univ. of Technology (China); Y. Zhang, F. Zhang, Harbin Institute of Technology (China)

8416 2C Comparative analysis of three-position measurement technology and multi-positions average measurement technology [8416-84]
P. Yang, Guiyang Univ. (China) and Institute of Optics and Electronics (China); F. Wu, X. Hou, Institute of Optics and Electronics (China)

8416 2D Research on SiO₂ film laser damage threshold [8416-42]
T. Wang, L. Yang, Xi'an Technological Univ. (China)

8416 2E Thermal-structural-optical analysis for the lens of high-precision interferometer [8416-40]
J. Zhang, Y. Wu, F. Wu, Institute of Optics and Electronics (China)

8416 2F Optical aligning and measuring methods for large aperture optical system [8416-110]
X. Zhang, R. Wei, J. Duan, J. Yang, H. Li, X. Hou, Xi'an Institute of Optics and Precision Mechanics (China)

8416 2G Noise factor of microchannel plate with ion barrier film [8416-99]
S. Liu, Science and Technology on Low-Light-Level Night Vision Lab. (China) and Institute of High Energy Physics (China); F. Shi, Z. Li, Y. Zhu, N. Zhang, Science and Technology on Low-Light-Level Night Vision Lab. (China); Y. Gu, J. Sun, X. Cong, H. Zhao, J. Pan, Y. Qian, S. Zheng, B. Chang, Nanjing Univ. of Science and Technology (China)

8416 2H Kinematical analysis of one-axis polisher acting on spherical mirror [8416-63]
L. Xu, J. Ding, Z. Ma, Q. Chen, Xi'an Institute of Optics and Precision Mechanics (China)

8416 2I Manufacturing of glass-based optical power splitter by ion-exchange method [8416-46]
Y. Xiao, J. Yang, M. Wang, Zhejiang Univ. (China)

8416 2J Design and experiments of a novel micro-displacement mechanism based on piezoelectricity actuator [8416-32]
Y. Li, Harbin Institute of Technology (China) and Heilongjiang Univ. of Chinese Medicine (China); J. Wang, W. Zhai, S. Dong, G. Li, Harbin Institute of Technology (China)
8416 2K **Self-generated magnetic fields in the relativistic laser-plasma interaction** [8416-95]
A. Abudurexiti, Xinjiang Univ. (China)

8416 2L **Preferential sputtering of Ar ion processing SiO_2 mirror** [8416-28]
G. Duan, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); T. Xing, Y. Li, Institute of Optics and Electronics (China)

8416 2M **Optimization of the edge extension in dwell time algorithm for ion beam figuring** [8416-37]
L. Shu, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); F. Wu, C. Shi, Institute of Optics and Electronics (China)

8416 2N **Hybrid refractive/diffractive optical system design for light and compact uncooled longwave infrared imager** [8416-68]
H. Wang, Northwestern Polytechnical Univ. (China) and Xi'an Institute of Optics and Precision Mechanics (China); Y. Bai, Institute of Optics and Electronics (China); J. Luo, Northwestern Polytechnical Univ. (China)

8416 2O **A new numerical calculation method for the characteristics of hydrostatic slide** [8416-20]
G. Hou, T. Sun, J. Zhou, E. Qi, Harbin Institute of Technology (China)

8416 2P **Research on theoretical analysis of active fluid jet polishing** [8416-213]
T. Sun, L. Sun, F. Wang, S. Liu, Dalian Institute of Chemical and Physics (China)

8416 2Q **Fabrication of supersmooth optical elements with low surface and subsurface damage** [8416-159]
G. Zhan, Z. Shen, B. Ma, X. Wang, Z. Wang, Tongji Univ. (China); H. Liu, Y. Ji, Tongji Univ. (China) and Tianjin Jinhang Institute of Technical Physics (China)

**Author Index**